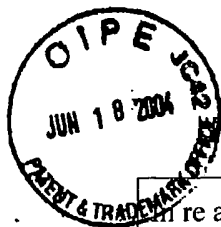


OIC to enter  
BT 6/29/04

AF 1765  
Sfaw



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of:

BASOL et al.

Serial No.: 09/841,622

Filed: April 23, 2001

Title: Electroetching Process And System

Group Art Unit: 1765

Examiner: TRAN, BINH X

Docket: NT-206-US

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the US Postal Service as First Class Mail in a postage-paid envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on June 15, 2004.

Signed:

Amy Alwine

AMENDMENT AF

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313

Dear Sir:

A) In response to the Office Action mailed June 1, 2004 with a shortened statutory period for response no later than September 1, 2004, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.